ALG-12-2003 13:42 FR

PATENT APPLICATION 042390.P10047

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

irrre application of:) August 12, 2003
Jian Li et al.)
out El et al.)
Serial No.: 09/897,174)
5511di 145.: 53/537,174) Group Art Unit: 2826
Filed: June 29, 2001)
20, 200) Examiner: T. Dickey
For: LOW-VOLTAGE AND INTERFACE	DAMAGE-EREE DOLVMER
MEMORY DEVICE	DAMAGE-FALL POLYMEN
I HEREBY CERTIFY THAT THIS DEPOSITED WITH THE UNITED ACCORDANCE WITH 37 CFR §1. ENVELOPE ADDRESSED TO:	STATES POSTAL SERVICE IN
HONORABLE DIRECTOR OF THE UN OFFICE,	ITED STATES PATENT AND TRADEMARK
WASHINGTON, D.C. 20231, ON:	8-13 03
	Date of Deposit
INTEL CORF	PORATION
Name of Assignee	
sas i aa	<u>8.1303</u>
SIGNATURE	DATE

RESPONSE

HONORABLE DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE, Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed June 4, 2003, please reconsider the above-identified patent application in view of the remarks below.